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Substitute for form 1449A/PTO		Complete If Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	Not yet assigned
		Filing Date	August 20, 2003
		First Named Inventor	Walton
		Group Art Unit	Not yet assigned
		Examiner Name	Not yet assigned
		Attorney Docket Number	NC 84,613
Sheet 1	of 2		

[illegible][illegible]

Examiner Signature	<i>Thaddeus McQuinn</i>	Date Considered	<i>12/21/04</i>
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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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PTO/SB/088 (08-00)
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Substitute for form 1449B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>		Compleat If Known	
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		First Named Inventor	Walton
		Group Art Unit	Not yet assigned
		Examiner Name	Not yet assigned
Sheet 2	of 2	Attorney Docket Number	NC 84,613

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
Jm		MEGER et al, "Bemed-Generated Plasmas for Processing Applications", Amer. Inst. of Physics, May 2001, Vol. 8 No. 5, pp. 2558-2564	
		LEONHARDT et al, "Plasma Diagnostic in Large area Plasma Processing System", Journal of Vacuum Science & Tech., July 2001, Vol. 19 No. 4, pp. 1367-1373	
		WALTON et al, "Ion Energy Distribution in a Pulsed, Electron Beam-Generated Plasma", Journal of Vacuum Science & Tech., July 2001, Vol 19 No. 4, pp. 1325-1329	
		MANHEIMER et al, "Theoretical Overview of the Large-Area Plasma Processing System (LAPPS)", Plasma Sources Science Technology, 2000, Vol 9, pp. 370-386	
Jm		FERNSLER et al, "Production of Large-Area Plasmas by Electron Beams", Amer. Inst. of Physics, May 1998, Vol5 No. 5, pp. 2137-2143	

Examiner Signature		Date Considered	12/21/09
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Application Number	10/644,567
Filing Date	August 20, 2003
First Named Inventor	Walton et al.
Group Art Unit	Not yet assigned
Examiner Name	Not yet assigned
Attorney Docket Number	84,613

Sheet 1 of 2

Attorney Docket Number 84,613

[illegible][illegible]

Rodney McDonald

12/21/04

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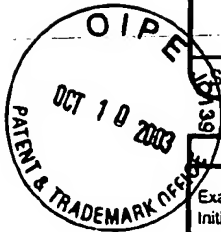
INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 2 of 2

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<i>[Signature]</i>		R. F. FERNSLER ET AL., "Production of large-area plasmas by electron beams," Phys. Plasmas, 1998, 5, 2137-2143	
		WALLACE M. MANHEIMER ET AL., "Theoretical overview of the large-area plasma processing system (LAPPS)," Plasma Sources Sci. Technol. 2000, 9, 370-386	
		S. G. WALTON ET AL., "Ion energy distributions in a pulsed, electron beam-generated plasma," J. Vac. Sci. Technol. A, 2001, 19(4), 1325-1329	
		D. LEONHARDT ET AL., "Plasma diagnostics in large area plasma processing system," J. Vac. Sci. Technol. A, 2001, 19(4), 1367-1373	
		R. A. MEGER ET AL., "Beam-generated plasmas for processing applications," Phys Plasmas, 2001, 8, 2558-2564	
<i>[Signature]</i>		KARL-HEINZ MULLER, "Stress and microstructure of sputter-deposited thin films: Molecular dynamics investigations," J. Appl. Phys., 1987, 62, 1796-1799	

Examiner
Signature

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